

OCT 25 2005

PATENT
90065.99R272 (17732.6323)
Response Under 37 CFR 1.111

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

Applicant: Jifa Hao, et al.)
Serial No.: 09/654,845)
Filed: September 01, 2000)
Title: POWER SEMICONDUCTOR)
DEVICE WITH HIGH)
AVALANCHE CAPABILITY AND)
PROCESS FOR FORMING)
SAME)

Examiner: Ori Nadav

Art Unit: 2811

RESPONSE UNDER 37 CFR 1.116

MS: Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action mailed October 11, 2005, Applicants hereby submit the following Amendment and Remarks.

